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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

Application Number	09/041,983
Filing Date	August 28, 2001
First Named Inventor	Fang
Art Unit	2823
Examiner Name	Lee, Hsien Ming
Attorney Docket Number	01 P 14755 US

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
Lee	A	US-4,357,203	11-02-1982	Zelex	
Lee	B	US-5,849,387	12-15-1998	Dixit, et al.	
		US-			
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
Lee	C	JP 02246246	10-02-1990	Fujitsu Ltd.		
	D	JP 2001217400	08-10-2001	Agilent Technologies, Inc.		
	E	JP 2001118846	10-18-1999	Sony Corp.		
	F	WO 01/29879 A2	04-26-2001	Mattson Technology, Inc., et al.		
	G	EP 1081751 A2	03-07-2001	Applied Materials, Inc.		
Lee	H	WO 00/34997	06-15-2000	Applied Materials, Inc.		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issu number(s), publisher, city and/or country where published.	T ²
Lee	I	ZHAO, B., et al., "Integration of Low Dielectric Constant Materials in Advanced Aluminum and Copper Interconnects," Mat. Res. Soc. Symp. Proc., Vol. 564, 1999 Materials Research Society, pp. 485-497.	

Examiner Signature	Hsien Ming Lee	Date Considered	4/19/04
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Sheet

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Complete if Known

Application Number	09/941,963
Filing Date	08/28/2001
First Named Inventor	Fang
Group Art Unit	2844 2823
Examiner Name	TBD H. Lee
Attorney Docket Number	01P14755 US

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
Lee	1	4,585,517		Stemple	04/29/1986	
Lee	2	5,043,299		Chang, et al.	08/27/1991	
Lee	3	6,132,564		Licata	10/17/2000	
Lee	4	6,169,036		Bhowmik, et al.	01/02/2001	

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Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Office ³	Number ⁴	Kind Code ⁵ (if known)				

Examiner Signature	<i>Kevin Ming Lee</i>	Date Considered	8/22/02
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Sheet	1	of	1
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Application Number	TBD
Filing Date	Herewith
First Named Inventor	Fang
Group Art Unit	TBD 2823
Examiner Name	TBD H. Lee
Attorney Docket Number	01P14755 US

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09/04/98

08/28/01

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**Examiner
Signature**

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